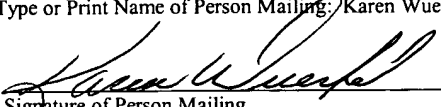


PATENT  
700623-3003

**In The United States Patent and Trademark Office**

<p>In re Application of:</p> <p>Assignee: Technologies and Devices International, Inc.</p> <p>Inventors: Yuri V. Melnik, <i>et al.</i></p> <p>App. No: 10/632,736</p> <p>Filed: August 1, 2003</p> <p>Title: Reactor for Extended Duration Growth of Gallium Containing Single Crystals</p> <p>Docket: 700623-3003</p>	<p>Art Unit: 1763</p> <p>Examiner: Moore, Karla A.</p> <p>CERTIFICATE OF MAILING UNDER 37 CFR § 1.8</p> <p>Date of Deposit: August 24, 2006</p> <p>I hereby certify that this document is being deposited with the United States Postal Service first class mail on the date indicated above in an envelope addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450.</p> <p>Type or Print Name of Person Mailing: Karen Wuerfel</p> <p> Signature of Person Mailing</p>
--	--

**AMENDMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Commissioner:

This Amendment is submitted in response to the non-final Office action dated February 24,  
2006.